

22/24

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Wayne G. Renken
Title: Process Condition Sensing Wafer And Data Analysis System
Application No.: 10/685,550 Filing Date: October 14, 2003
Examiner: Charles D. Garber Group Art Unit: 2856
Docket No.: SENS.005US1 Conf. No.: 4924

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

This is in response to the non-final Office Action dated June 29, 2004, setting a period for response expiring on September 29, 2004.

Claim Amendments are reflected in the listing of claims, which begins on page 2 of this paper.

Drawing Amendments are not being made.

Specification Amendments are not being made.

Remarks begin on page 7 of this paper.

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